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Substitute Form PTO-1449 (Modified)	a.o. Doparamorn of Collington		Application No. 09/824,965	
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Tomohiro Kawase et al		
		Filing Date April 3, 2001	Group Art Unit 1765	

			U.S. Patent	Documents			
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M	AY	Influence of Melt Preparation on Residual Impurity Concentration in Semi-Insulating LEC GaAs, Johji Nishio and Kazutaka Terashima, Journal of Crystal Growth 96 (1989) 605-608, North-Holland, Amsterdam			

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